	/		
	Hit s	Search Text	DBs
21	34	Pd or Cu or copper or tin or	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB
22	0	polycarbonate or polyimide)) and	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB
23	3	photoresist) same (acrylate or	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB

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	s	Search Text	DBs	
24		photoresist) same (acrylate or polycarbonate or polyimide)) and	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	
25	2	near6 layer)) same (resist or photoresist) same (acrylate or	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	
26	3	((substrate or wafer or device or platen or surface) same (mask\$4 or pattern) same (ITO or (transparent near4 conductive near6 layer)) same (resist or photoresist) same (acrylate or	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB	

	Hit s	Search Text	DBs
27	219	or pattern) same (ITO or (transparent near4 conductive near6 layer)) same (resist or	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB
28	390	<pre>(resist or photoresist)) and ((metal\$4 or conductive or Sn or Pd or Cu or copper or tin or halladium) same (selectives3</pre>	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB